

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of: Wen-Song Tseng, et al.

Serial No.: 10/761,002                      Group Art Unit: 1634

Filed: January 20, 2004                      Examiner: F. Toledo

For: **WET BENCH WAFER FLOATING DETECTION SYSTEM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE UNDER 37 CFR §1.116(a)**

Sir:

In response to the Office Action of November 6, 2006, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.